



**ELECTRONIC COPY**

LG799608572  
Report verification at igi.org



May 15, 2026  
IGI Report Number **LG799608572**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **7.15 X 5.06 X 3.35 MM**

**GRADING RESULTS**

Carat Weight **1.03 CARAT**

Color Grade **D**

Clarity Grade **VS 1**

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MODIFIED BRILLIANT**

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**GRADING RESULTS**

Carat Weight **1.03 CARAT**

Color Grade **D**

Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

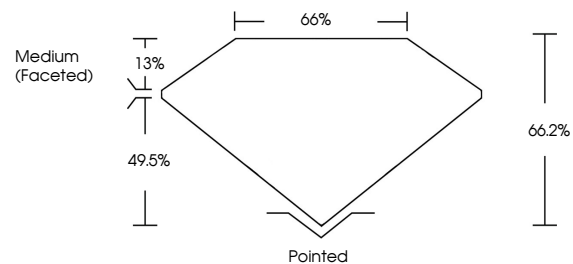
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG799608572**

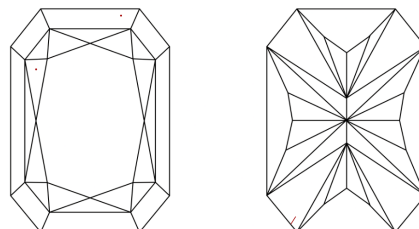
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

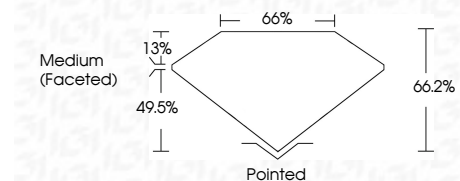
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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CUT CORNERED RECT. MODIFIED BRILLIANT  
7.15 X 5.06 X 3.35 MM  
Carat Weight 1.03 CARAT  
Color Grade D  
Clarity Grade VS 1  
Table 66.2%  
Girdle 65%  
Medium (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG799608572  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa